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(54) Title: SOLDER ALLOY

(57) Abstract: An alloy suitable for use in a wave solder process, reflow soldering process, hot air levelling process or a ball grid array, the alloy comprising from 0.08 - 3 wt.% bismuth, from 0.15 - 1.5 wt.% copper, from 0.1 - 1.5 wt.% silver, from 0 - 0.1 wt.% phosphorus, from 0 - 0.1 wt.% germanium, from 0 - 0.1 wt.% gallium, from 0 - 0.3 wt.% of one or more rare earth elements, from 0 - 0.3 wt.% indium, from 0 - 0.3 wt.% magnesium, from 0 - 0.3 wt.% calcium, from 0 - 0.3 wt.% silicon, from 0 - 0.3 wt.% aluminium, from 0 - 0.3 wt.% zinc, and at least one of the following elements from 0.02 - 0.3 wt.% nickel, from 0.008 - 0.2 wt.% manganese, from 0.01 - 0.3 wt.% cobalt, from 0.01 - 0.3 wt.% chromium, from 0.02 - 0.3 wt.% iron, and from 0.008 - 0.1 wt.% zirconium, and the balance tin, together with unavoidable impurities.

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### Solder Alloy

The present invention relates to an alloy and, in particular, a lead-free solder alloy. The alloy is particularly, though not exclusively, suitable for use in electronic soldering applications such as wave soldering, reflow soldering, hot air levelling and ball grid arrays and chip scale packages.

For environmental reasons, there is an increasing demand for lead-free replacements for lead-containing conventional alloys. Many conventional solder alloys are based around the tin-copper eutectic composition, Sn-0.7 wt.% Cu. EP-A-0 336 575 describes a low toxicity alloy composition for joining and sealing and, in particular, a lead-free alloy for use as a plumbing solder.

Wave soldering (or flow soldering) is a widely used method of mass soldering electronic assemblies. It may be used, for example, for through-hole circuit boards, where the board is passed over a wave of molten solder, which laps against the bottom of the board to wet the metals surfaces to be joined.

Another soldering process involves immersing printed wiring boards into molten solder in order to coat the copper terminations with a solderable protective layer. This process is known as hot air levelling.

A ball grid array joint or chip scale package is assembled typically with spheres of solder between two

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substrates. Arrays of these joints are used to mount chips on circuit boards.

US 2002/0051728 relates to a solder ball for use in a bump connection in a semiconductor device. Lead-containing and lead-free solder alloy compositions are described. An example is provided of a lead-free solder alloy having the composition Sn-2.5Ag-0.5Cu-1Bi.

10 However, problems are associated with some conventional lead-free eutectic or near eutectic solder compositions when used in wave soldering, reflow soldering, hot air levelling processes and ball grid arrays. In particular, conventional solder alloys in wave soldering often require high operating  
15 temperatures in order to obtain adequate soldering results without substantial faults on the board, such as webbing and bridging of solder between component terminations. The high temperatures used increase the rate of dross formation and the likelihood of excessive warping of the printed wiring  
20 board.

There are a number of requirements for a solder alloy to be suitable for use in wave soldering, reflow soldering, hot air levelling processes and ball grid arrays. First,  
25 the alloy must exhibit good wetting characteristics in relation to a variety of substrate materials such as copper, nickel, nickel phosphorus ("electroless nickel"). Such substrates may be coated to improve wetting, for example by using tin alloys, gold or organic coatings (OSP). Good  
30 wetting also enhances the ability of the molten solder to flow into a capillary gap, and to climb up the walls of a

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through-plated hole in a printed wiring board, to thereby achieve good hole filling.

Solder alloys tend to dissolve the substrate and to form an intermetallic compound at the interface with the substrate. For example, tin in the solder alloy may react with the substrate at the interface to form an intermetallic compound layer. If the substrate is copper, then a layer of  $\text{Cu}_6\text{Sn}_5$  will be formed. Such a layer typically has a thickness of from a fraction of a micron to a few microns. At the interface between this layer and the copper substrate an intermetallic compound of  $\text{Cu}_3\text{Sn}$  may be present. The interface intermetallic layers will tend to grow during aging, particularly where the service is at higher temperatures, and the thicker intermetallic layers, together with any voids that may have developed may further contribute to premature fracture of a stressed joint.

Other important factors are: (i) the presence of intermetallics in the alloy itself, which results in improved mechanical properties; (ii) oxidation resistance, which is important in solder spheres where deterioration during storage or during repeated reflows may cause the soldering performance to become less than ideal; (iii) drossing rate; and (iv) alloy stability. These latter considerations are important for applications where the alloy is held in a tank or bath for long periods of time.

The present invention aims to address at least some of the problems associated with the prior art and to provide an improved solder alloy. Accordingly, the present invention provides an alloy suitable for use in a wave solder process,

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a reflow soldering process, hot air levelling process, a ball grid array or chip scale package, the alloy comprising

5 from 0.08 - 3 wt.% bismuth,  
from 0.15 - 1.5 wt.% copper,  
from 0.1 - 1.5 wt.% silver,  
  
from 0 - 0.1 wt.% phosphorus,  
from 0 - 0.1 wt.% germanium,  
10 from 0 - 0.1 wt.% gallium,  
from 0 - 0.3 wt.% of one or more rare earth elements,  
from 0 - 0.3 wt.% indium,  
from 0 - 0.3 wt.% magnesium,  
from 0 - 0.3 wt.% calcium,  
15 from 0 - 0.3 wt.% silicon,  
from 0 - 0.3 wt.% aluminium,  
from 0 - 0.3 wt.% zinc,

and at least one of the following elements

20 from 0.02 - 0.3 wt% nickel,  
from 0.008 - 0.2 wt% manganese,  
from 0.01 - 0.3 wt% cobalt,  
from 0.01 - 0.3 wt% chromium,  
25 from 0.02 - 0.3 wt% iron,  
from 0.008 - 0.1 wt% zirconium,

and the balance tin, together with unavoidable impurities.

30 The present invention will now be further described. In the following passages different aspects of the invention are defined in more detail. Each aspect so defined may be

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combined with any other aspect or aspects unless clearly indicated to the contrary. In particular, any feature indicated as being preferred or advantageous may be combined with any other feature or features indicated as being preferred or advantageous.

The presence of bismuth provides strengthening of the alloy via its presence in solid solution at low concentration levels, and as bismuth rich particles or bismuth containing intermetallics at higher levels. Its presence improves the mechanical properties of the solder alloy for the applications in question, i.e. wave soldering, reflow soldering, hot air levelling, ball grid arrays and chip scale packages. The bismuth content also contributes to the reduction in the growth rate of Cu-Sn intermetallics at the interface which leads to improved mechanical properties of the solder joints made using the alloys. For this reason, the alloy according to the present invention preferably comprises from 0.08 to 1 wt.% Bi, more preferably from 0.08 to 0.5 wt.% Bi, still more preferably from 0.08 to 0.3 wt.% Bi, still more preferably from 0.08 to 0.2 wt.% Bi. A useful lower limit is considered to be 0.08wt%, and for this reason the lower limit in respect of the bismuth is typically 0.1 wt.%, more typically 0.12 wt.% or 0.14 wt.%. However, the content of bismuth in the alloy does not exceed 3 wt%. Higher levels of bismuth lower the melting point and reduce the ductility of the alloy, for example making fabrication into wire much more difficult. For these reasons, the content of bismuth in the alloy preferably does not exceed 1 wt%, more preferably it does not exceed 0.5 wt.%, more preferably it does not exceed 0.4 wt.%, still more preferably it does not exceed 0.3 wt.%. In view of the

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foregoing, in a preferred embodiment, the present invention provides an alloy as described herein and which contains from 0.10 - 0.3 wt% Bi, more preferably 0.12 - 0.3 wt% Bi.

The alloy preferably comprises from 0.15 to 1 wt.% Cu, 5 more preferably from 0.5 to 0.9 wt.% Cu, still more preferably from 0.6 to 0.8 wt.% Cu.

The alloy preferably comprises from 0.1 to 1.3 wt.% Ag, more preferably from 0.1 to 1 wt.% Ag, still more preferably 10 from 0.1 to 0.5 wt.% Ag, still more preferably from 0.1 to 0.4 wt.% Ag, still more preferably from 0.2 to 0.4 wt.% Ag. In combination with the other alloying elements, a silver content within these ranges has been found to provide the alloy with the necessary properties for the applications in 15 question. Furthermore, it has been found that molten alloys with lower silver content have the advantage of producing lower copper dissolution rates. For this reason, the content of silver in the alloy preferably does not exceed 1.1 wt.%, more preferably it does not exceed 0.5 wt.%, still 20 more preferably it does not exceed 0.4 wt.%.

Copper forms an eutectic with tin, lowering the melting point and increasing the alloy strength. A copper content in the hyper-eutectic range increases the liquidus 25 temperature but further enhances the alloy strength. Silver further lowers the melting point and improves the wetting properties of the solder to copper and other substrates. Bismuth also improves the alloy strength and, depending on the concentration chosen, will reduce the melting point 30 still further.

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The alloy preferably comprises from 0.02 - 0.2 wt.% of at least one of nickel, cobalt, iron and chromium, more preferably from 0.02 - 0.1 wt.% of at least one of nickel, cobalt, iron and chromium.

5

If present, the alloy preferably comprises from 0.005 - 0.3 wt.% magnesium. Improved properties can be obtained by the presence of from 0.02 - 0.3 wt% Fe in conjunction with from 0.005 - 0.3 wt.% magnesium.

10

If present, the alloy preferably comprises from 0.01 - 0.15 wt% manganese, more preferably from 0.02 - 0.1 wt% manganese.

15

Nickel, cobalt, chromium, manganese and zirconium may act as intermetallic compound growth modifiers and grain refiners. For example, while not wishing to be bound by theory, it is believed that nickel forms an intermetallic with tin and substitutes for the copper to form a CuNiSn intermetallic. Nickel may also form an intermetallic with bismuth. The presence of nickel in the alloy has been found to have an advantageous effect in that it reduces the dissolution rate of the thin copper layers on printed circuit boards. In some cases, where there are large areas of bare copper being wetted by the solder, this attribute is helpful to maintain the stability of the solder composition and prevent undue build-up of the copper level. This has particular value in, for example, hot air solder levelling since the potential for problems being caused by the change in the solder bath composition (for example an increase in the copper level) are reduced. For these reasons, the alloy according to the present invention preferably comprises at

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25  
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least 0.03 wt.% Ni, for example from 0.03 wt.% to 0.3 wt.% Ni.

If the service conditions limit the maximum  
5 temperature, and there is a need for the molten alloy to have good flow properties through holes or in capillary gaps, then it advantageous if the nickel level does not exceed 0.1 wt.%, more preferably if it does not exceed 0.06 wt.%. Accordingly, in one preferred embodiment, the present  
10 invention provides an alloy as herein described and which contains from 0.03 - 0.1 wt% Ni, more preferably from 0.03 - 0.06 wt% Ni.

On the other hand, where maximum effects from grain  
15 refinement and strength are desirable and can be accommodated by higher operating temperatures, then the alloy preferably contains at least 0.05 wt.% Ni, more preferably at least 0.07 wt.% Ni, still more preferably at least 0.1 wt.% Ni. Accordingly, in another preferred  
20 embodiment, the present invention provides an alloy as herein described and which contains from 0.05 - 0.3 wt% Ni, more preferably from 0.07 - 0.3 wt% Ni, still more preferably from 0.1 - 0.3 wt% Ni.

25 Furthermore the presence of nickel in the low silver and bismuth containing alloy provides a great practical benefit in improving the resistance to so called "drop shock" failure (brittle fracture) of a ball grid array or chip scale package made with these solders in form of a  
30 sphere, or a solder paste. This benefit is believed to be derived from the reduced growth rate of the intermetallics at the interface between solder and substrate caused by

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thermal aging which occurs during service. It has been found that the growth rates of the copper - solder interface intermetallics are less than in nickel free alloys of the Sn-Ag-Cu-Bi system.

5

Iron is believed to have a similar effect to nickel and the comments above in relation to nickel are therefore also applicable to iron. For the reasons outlined above, the alloy preferably comprises at least 0.03 wt.% Fe, for  
10 example from 0.03 wt.% to 0.3 wt.% Fe.

Manganese, cobalt and chromium each have low solubility in tin and are also believed to form intermetallics with copper and tin. Chromium has some solubility in copper and  
15 therefore has the potential to substitute for copper in Cu-Sn intermetallics in the same manner as nickel. The presence of the intermetallics affects the microstructure developed on cooling the alloy from the molten to the solid state. A finer grain structure is observed, which further  
20 benefits the appearance and strength of the alloy.

Cobalt has also been found to reduce the rate of dissolution of copper and to slow the rate of interface intermetallic formation, while not having an adverse effect  
25 on the solder wetting speed. For this reason, the alloy preferably comprises at least 0.02 wt.% Co, more preferably at least 0.05 wt.% Co, more preferably at least 0.07 wt.% Co, still more preferably at least 0.1 wt.% Co. However, if the service conditions limit the maximum temperature, and  
30 there is a need for the molten alloy to have good flow properties though holes or in capillary gaps, then it may be preferable if the cobalt level does not exceed 0.1 wt.%,

- 10 -

more preferably if it does not exceed 0.07 wt.%.

Accordingly, in one preferred embodiment, the present invention provides an alloy as herein described and which contains from 0.02 - 0.07 wt.% Co, more preferably from 0.02  
5 - 0.05 wt% Co. The presence of Co provides a similar benefit to that of Ni when it is used in the composition in combination with the other elements of the invention as a solder in ball grid arrays and chip scale packaging. Drop shock failure resistance is enhanced.

10

Chromium has also been found to harden the alloy. Accordingly, for certain applications where it is desired to avoid a brittle alloy, it is preferable if the chromium content in the alloy does not exceed 0.2 wt.%, more  
15 preferably if the chromium content does not exceed 0.1 wt.%. A preferred range is from 0.02 to 0.1 wt.% Cr, more preferably from 0.02 to 0.08 wt.% Cr, still more preferably from 0.02 to 0.06 wt.% Cr.

20

The present inventors have also found that the presence of chromium in the alloy has a considerable benefit in the ability to reduce the rate of oxidation of spheres of solder. Accordingly, for certain applications, it may be preferable if the alloy comprises at least 0.02 wt.% Cr,  
25 preferably at least 0.05 wt.% Cr, more preferably at least 0.06 wt.% Cr, still more preferably at least 0.07 wt.% Cr. In one preferred embodiment, the present invention provides a solder sphere comprising an alloy as herein described and which contains from 0.02 - 0.3 wt.% Cr, more preferably from  
30 0.05 - 0.3 wt.% Cr, still more preferably from 0.07 - 0.3 wt.% Cr.

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Both zirconium and manganese have been found to reduce the rate of interface intermetallic growth.

Indium, zinc and aluminium may act as diffusion  
5 modifiers. Indium has been found to have a beneficial effect on solder wetting. Indium lowers the melting point of the solder. Indium may also act to reduce the formation of voids in the solder joint. Indium may also improve the strength of the Sn-rich matrix. Zinc has been found to act  
10 in a similar manner to indium.

Aluminium and magnesium have been found to alter the shape of the intermetallic phases present in the bulk alloy, providing a benefit in some production applications where  
15 alloy must pass through narrow nozzles without blockage caused by build up of unmelted intermetallic in the entry zone of the nozzle.

Phosphorus, germanium and gallium may act to reduce the  
20 volume of dross formed on the top of an open tank of solder, and are thus valuable additions in, for example, wave solder baths.

If present, the alloy preferably comprises up to 0.05  
25 wt.% of one or more rare earth elements. The one or more rare earth elements preferably comprise two or more elements selected from cerium, lanthanum, neodymium and praseodymium.

The alloys will typically comprise at least 90 wt.%  
30 tin, preferably from 94 to 99.6 % tin, more preferably from 95 to 99 % tin, still more preferably 97 to 99 % tin. Accordingly, the present invention further provides an alloy

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for use in a wave solder process, **reflow soldering process**, hot air levelling process, a ball grid array or chip scale package, the alloy comprising

5           from 0.08 - 3 wt.% bismuth,  
          from 0.15 - 1.5 wt.% copper,  
          from 0.1 - 1.5 wt.% silver,  
          from 95 - 99 wt% tin,

10           from 0 - 0.1 wt.% phosphorus,  
          from 0 - 0.1 wt.% germanium,  
          from 0 - 0.1 wt.% gallium,  
          from 0 - 0.3wt.% of one or more rare earth elements,  
          from 0 - 0.3 wt.% indium,

15           from 0 - 0.3 wt.% magnesium,  
          from 0 - 0.3 wt.% calcium,  
          from 0 - 0.3 wt.% silicon,  
          from 0 - 0.3 wt.% aluminium,  
          from 0 - 0.3 wt.% zinc,

20

and at least one of the following elements

          from 0.02 - 0.3 wt% nickel,  
          from 0.008 - 0.2 wt% manganese,  
25           from 0.01 - 0.3 wt% cobalt,  
          from 0.01 - 0.3 wt% chromium,  
          from 0.02 - 0.3 wt% iron, and  
          from 0.008 - 0.1 wt% zirconium,

30 together with unavoidable impurities.

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The alloys according to the present invention may consist essentially of the recited elements. It will therefore be appreciated that in addition to those elements which are mandatory (i.e. Sn, Cu, Bi, Ag and at least one of  
5 Ni, Co, Mn, Fe, Zr and Cr) other non-specified elements may be present in the composition provided that the essential characteristics of the composition are not materially affected by their presence. Accordingly, the present invention still further provides an alloy for use in a wave  
10 solder process, reflow soldering process, hot air levelling process, a ball grid array or chip scale package, the alloy consisting essentially of:

from 0.08 - 3 wt.% bismuth,  
15 from 0.15 - 1.5 wt.% copper,  
from 0.1 - 1.5 wt.% silver,  
from 95 - 99 wt% tin,  
  
from 0 - 0.1 wt.% phosphorus,  
20 from 0 - 0.1 wt.% germanium,  
from 0 - 0.1 wt.% gallium,  
from 0 - 0.3wt.% of one or more rare earth elements,  
from 0 - 0.3 wt.% indium,  
from 0 - 0.3 wt.% magnesium,  
25 from 0 - 0.3 wt.% calcium,  
from 0 - 0.3 wt.% silicon,  
from 0 - 0.3 wt.% aluminium,  
from 0 - 0.3 wt.% zinc,

30 and at least one of the following elements

from 0.02 - 0.3 wt% nickel,

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from 0.008 - 0.2 wt% manganese,  
from 0.01 - 0.3 wt% cobalt,  
from 0.01 - 0.3 wt% chromium,  
from 0.02 - 0.3 wt% iron, and  
5 from 0.008 - 0.1 wt% zirconium,

together with unavoidable impurities.

The present invention also provides for the use of the  
10 following solder alloy composition in a ball grid array or  
chip scale package:

from 0.08 - 3 wt.% bismuth,  
from 0.15 - 1.5 wt.% copper,  
from 0.1 - 1.5 wt.% silver,  
15 from 0 - 0.1 wt.% phosphorus,  
from 0 - 0.1 wt.% germanium,  
from 0 - 0.1 wt.% gallium,  
from 0 - 0.3 wt.% of one or more rare earth elements,  
from 0 - 0.3 wt.% indium,  
20 from 0 - 0.3 wt.% magnesium,  
from 0 - 0.3 wt.% calcium,  
from 0 - 0.3 wt.% silicon,  
from 0 - 0.3 wt.% aluminium,  
from 0 - 0.3 wt.% zinc,

25 and the balance tin, together with unavoidable impurities.  
The present invention also provides for a ball grid array  
joint comprising the above solder alloy composition.

The alloys according to the present invention are lead-  
30 free or essentially lead-free. The alloys offer  
environmental advantages over conventional lead-containing  
solder alloys.

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The alloys according to the present invention will typically be supplied as a bar, stick or ingot, optionally together with a flux. The alloys may also be provided in  
5 the form of a wire, for example a cored wire, which incorporates a flux, a sphere, or other preform typically though not necessarily made by cutting or stamping from a strip or solder. These may be alloy only or coated with a suitable flux as required by the soldering process. The  
10 alloys may also be supplied as a powder, or as a powder blended with a flux to produce a solder paste.

The alloys according to the present invention may be used in molten solder baths as a means to solder together  
15 two or more substrates and/or for coating a substrate.

It will be appreciated that the alloys according to the present invention may contain unavoidable impurities, although, in total, these are unlikely to exceed 1 wt.% of  
20 the composition. Preferably, the alloys contain unavoidable impurities in an amount of not more than 0.5 wt.% of the composition, more preferably not more than 0.3 wt.% of the composition, still more preferably not more than 0.1 wt.% of the composition.

25

The alloys according to the present invention are particularly well suited to applications involving wave soldering, **reflow soldering**, hot air levelling or ball grid arrays and chip scale packaging. The alloys according to  
30 the present invention may also find application in non-electronic applications such as, for example, plumbing and automotive radiators.



**Examples**

The following are non-limiting examples to further  
5 describe the present invention.

Example 1

An alloy was prepared by melting Sn in a cast iron  
10 crucible (alternatively a ceramic crucible can be used). To  
the molten Sn was added an alloy of Sn-3wt% Cu, elemental  
Bi, and alloys of Sn-5 wt% Ag and Sn-0.6wt%Ni. These  
additions were made with the alloy bath temperature at  
350°C. The bath was cooled to 300°C for the addition of  
15 phosphorus in the form of an alloy Sn-0.3%P.

The alloy was sampled to verify the composition of

20	Ag	0.3wt%
	Cu	0.7 wt%
	Bi	0.12 wt%
	Ni	0.04 wt%
	P	0.005 wt%.
	and remainder tin	

25

The alloy was cast into an ingot. It was later re-  
melted into a solder bath serving a wave soldering machine.  
The molten alloy at a bath temperature of 260°C was pumped  
to produce two solder waves close to each other.

30

The machine was used to produce joints between  
components and the board terminations on a range of single

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and double sided printed circuit boards. Incidence of faults requiring repair was very low and the surface of the soldered joints was attractively bright and readily inspected.

5

#### Example 2

The alloy according to Example 1 may also be used in a hot air solder levelling bath. The temperature is set at  
10 260°C, and the machine set so that contact times with the solder boards ranged from 2.5 seconds at the top of the PCB boards and 5 seconds at the base of the board. Air knife temperatures were 295C. Excellent tinning results were achieved with clean surface finish and consistent tinning  
15 thickness.

#### Example 3

The following alloy composition was prepared (all  
20 wt.%).

Ag	0.3
Cu	0.6
Bi	0.13
25 Ni	0.03
Co	0.02
P	0.004
Sn	balance

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This alloy was prepared in a similar manner to example 1. Cobalt was added in the form of a master alloy of Sn-0.3wt% Co. The solder was loaded into a wave solder bath, melted, and the temperature set at 260°C. Solder boards were fluxed with AlphaFry EF6000 flux, and the boards then wave soldered. Joints were formed cleanly, the level of bridging was low, and the hole fill was excellent.

10 Example 4

The following alloy composition was prepared in a similar manner to Example 1 (all wt.%).

15	Ag	0.34
	Cu	0.72
	Bi	0.25
	Ni	0.03
	P	0.003
20	Sn	balance

This alloy may also be used in a wave solder bath. Double sided FR4 test boards containing a large connector block, Quad flat pack IC's with a range of lead pitches, SOT 23 and chip resistors and capacitors were fluxed with AlphaFry flux EF6000 and passed over wave at 260°C Good soldering results were obtained on a deliberately challenging board layout with minimal bridging and skips present.

Example 5

Alloys have been prepared corresponding to the  
5 compositions of Examples 2 to 5 where Ge at 0.007 wt.% is  
substituted for the phosphorus content.

Example 6

10 The following alloy composition was prepared in a  
similar manner to Example 1 (all wt.%).

	Ag	0.35
	Cu	0.65
15	Bi	0.14
	Co	0.20
	P	0.005%
	Sn	balance

20 This alloy may be provided in the form of a sphere and  
used in a ball grid array or chip scale package joint.

Example 7

25 The following alloy composition was prepared in a  
similar manner to Example 1 (all wt.%).

- 20 -

	Ag	0.35
	Cu	0.7
	Bi	0.13
5	Co	0.10
	Ge	0.10
	Sn	balance

This alloy may be provided in the form of a sphere and  
10 used in a ball grid array or chip scale package joint.

#### Example 8

The following alloy composition was prepared in a  
15 similar manner to Example 1 (all wt.%).

	Ag	1.1
	Cu	1.1
	Bi	0.15
20	Ni	0.06
	Co	0.02%
	Sn	balance

This alloy may be provided in the form of a preform or  
25 sphere.

Example 9

The following alloy composition was prepared in a similar manner to Example 1. Germanium was provide by  
5 manufacture of a master alloy of Sn -0.3% Ge.

	Ag	0.3
	Cu	0.7
	Bi	0.1
10	Ni	0.10
	Ge	0.10
	P	0.006
	Sn	balance

15 This alloy may be provided in the form of a sphere and used in a ball grid array joint or chip scale package.

Example 10

20 The alloy composition according to Example 9 was punched into a disc, which was then melted and spherodised as a sphere.

Example 11

25

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The following alloy composition was prepared in a similar manner to Example 1 (all wt.%).

	Ag	0.4
5	Cu	0.6
	Bi	0.14
	Ni	0.05
	In	0.15
	Ge	0.005%
10	Sn	balance

This alloy may be provided in the form of a sphere.

#### Example 12

15

The following alloy composition was prepared in a similar manner to Example 1 (all wt.%). A tin chromium master alloy containing 0.25%Cr had been prepared in a vacuum furnace.

20

	Ag	0.3
	Cu	0.65
	Bi	0.12
	Cr	0.05
25	P	0.006
	Sn	balance

This alloy may be provided in the form of a sphere.

Example 13

The following alloy composition was prepared in a  
5 similar manner to Example 1 (all wt.%).

	Ag	0.3
	Cu	0.7
	Bi	0.1
10	Ni	0.2
	P	0.006
	Sn	balance

This alloy may be provided in the form of a sphere and  
15 used in a ball grid array or chip scale package joint.

Example 14

The following alloy composition was prepared by melting  
20 the elements in a vacuum furnace.

	Ag	1.1
	Cu	1.1
	Bi	0.1
25	Fe	0.25
	Mg	0.01



- 24 -

Sn balance

This alloy may be provided in the form of a sphere and used in a ball grid array joint.

5

Example 15

Ten BGA packages, each individually daisy chained, were prepared by reflow soldering using solder spheres of the following alloy compositions.

10

A Ag 3.0 wt%  
Cu 0.5 wt%  
Sn remainder

15 B Ag 0.3 wt%  
Cu 0.7 wt%  
Bi 0.1 wt%  
Sn remainder

20 C Ag 0.3 wt%  
Cu 0.7 wt%  
Bi 0.1 wt%  
Ni 0.05 wt%  
Sn remainder

25

They were each subjected to 1500g shock pulses of 0.5 milli second duration to simulate drop shock impact stress loading. At all stages the assemblies were monitored to track the condition of the solder joints using a 64 channel  
30 on line resistance monitor so that failure due to resistance change could be established.

- 25 -

The shocks were repeated and the incidence of failed joints was recorded.

- 5 After only 3 shocks loadings, 10% of the Sn-3.0Ag-0.5Cu joints had failed, whereas those made in alloy B survived to 50 drops, and in alloy C to 120 drops before the same incidence of failure was recorded.
- 10 A 25 % failure rate was found in alloy A after 8 drops, in alloy B after 100 drops , and alloy C survived 200 drops.

This improved resistance to brittle drop shock failure is of considerable practical value.

15

#### Example 16

An alloy was prepared by melting Sn in a cast iron  
20 crucible (alternatively a ceramic crucible can be used). To the molten Sn was added an alloy of Sn-3wt% Cu, and alloys of Sn-5 wt% Ag and Sn-0.35wt%Ni. These additions were made with the alloy bath temperature at 350°C. The bath was cooled to 300°C for the addition of phosphorus in the form  
25 of an alloy Sn-0.3%P.

The alloy was sampled to verify the composition of

30 Ag 0.3 wt%  
Cu 0.7 wt%  
Bi 0.1 wt%  
P 0.006 wt%.

- 26 -

and remainder tin

The alloy composition was then jetted as a metal stream into an inerted vertical column. The metal stream was  
5 spherodised by the application of magnetostrictive vibrational energy applied through the melt pot and at or near the exit orifice.

Equally, the alloy composition could be punched and  
10 then spherodised as a sphere.

The alloy, provided in the form of a sphere can be used in a ball grid array joint. Flux is printed or pin transferred to the pads of a CSP. The spheres are then pick  
15 and placed or shaken through a stencil onto the fluxed pads. The package is then reflowed in a standard reflow oven at a peak temperature of between 240°C and 260°C.

Alloy and solder joint performance was assessed in  
20 packages aged at 150°C for up to 1000 hours. IMC growth was measured by standard metallographic techniques. Mechanical ball pull testing was used to assess solder joint failure mode (brittle or ductile).

**CLAIMS:**

1. An alloy suitable for use in a wave solder process,  
reflow soldering process, hot air levelling process, a ball  
5 grid array or chip scale package, the alloy comprising

from 0.08 - 3 wt.% bismuth,  
from 0.15 - 1.5 wt.% copper,  
from 0.1 - 1.5 wt.% silver,

10

from 0 - 0.1 wt.% phosphorus,  
from 0 - 0.1 wt.% germanium,  
from 0 - 0.1 wt.% gallium,  
from 0 - 0.3wt.% of one or more rare earth elements,

15

from 0 - 0.3 wt.% indium,  
from 0 - 0.3 wt.% magnesium,  
from 0 - 0.3 wt.% calcium,  
from 0 - 0.3 wt.% silicon,  
from 0 - 0.3 wt.% aluminium,

20

from 0 - 0.3 wt.% zinc,

and at least one of the following elements

from 0.02 - 0.3 wt% nickel,  
25 from 0.008 - 0.2 wt% manganese,  
from 0.01 - 0.3 wt% cobalt,  
from 0.01 - 0.3 wt% chromium,  
from 0.02 - 0.3 wt% iron, and  
from 0.008 - 0.1 wt% zirconium,

30

and the balance tin, together with unavoidable impurities.

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2. An alloy as claimed in claim 1 comprising from 0.08 to 1 wt.% Bi.
3. An alloy as claimed in claim 2 comprising from 0.08 to 5 0.5 wt.% Bi.
4. An alloy as claimed in claim 3 comprising from 0.08 to 0.3 wt.% Bi, preferably from 0.10 - 0.3 wt% Bi, more preferably from 0.12 - 0.3 wt% Bi.
- 10 5. An alloy as claimed in any one of the preceding claims comprising from 0.15 to 1 wt.% Cu.
6. An alloy as claimed in claim 5 comprising from 0.5 to 15 0.9 wt.% Cu.
7. An alloy as claimed in claim 6 comprising from 0.6 to 0.8 wt.% Cu.
- 20 8. An alloy as claimed in any one of the preceding claims comprising from 0.1 to 1 wt.% Ag.
9. An alloy as claimed in claim 8 comprising from 0.1 to 0.5 wt.% Ag.
- 25 10. An alloy as claimed in claim 9 comprising from 0.2 to 0.4 wt.% Ag.
11. An alloy as claimed in any one of the preceding claims 30 comprising from 0.02 - 0.2 wt.% of at least one of Ni, Co, Fe and Cr.

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12. An alloy as claimed in claim 11 comprising from 0.02 - 0.1 wt.% of at least one of Ni, Co, Fe and Cr.
13. An alloy as claimed in any one of claims 1 to 10  
5 comprising from 0.03 - 0.3 wt.% Ni.
14. An alloy as claimed in claims 13 comprising from 0.03 - 0.1 wt.% Ni, preferably from 0.03 - 0.06 wt% Ni.
- 10 15. An alloy as claimed in claims 13 comprising from 0.05 - 0.3 wt% Ni, preferably from 0.07 - 0.3 wt% Ni.
16. An alloy as claimed in any one of the preceding claims comprising from 0.02 - 0.07 wt.% Co, preferably from 0.02 -  
15 0.05 wt% Co.
17. An alloy as claimed in any one of the preceding claims comprising from 0.02 to 0.08 wt.% Cr, preferably from 0.02 to 0.06 wt.% Cr.  
20
18. An alloy as claimed in any one of claims 1 to 16 comprising from 0.02 - 0.3 wt.% Cr, preferably from 0.05 - 0.3 wt.% Cr.
- 25 19. An alloy as claimed in any one of the preceding claims comprising from 0.005 - 0.3 wt.% Mg.
20. An alloy as claimed in claim 19 comprising from 0.02 - 0.1 wt% Fe.  
30
21. An alloy as claimed in any one of the preceding claims comprising from 0.01 - 0.15 wt.% Mn.

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22. An alloy as claimed in claim 21 comprising from 0.02 - 0.1 wt.% Mn.
- 5 23. An alloy as claimed in any one of the preceding claims comprising from 0.05 - 0.3 wt.% In.
24. An alloy as claimed in claim 23 comprising from 0.1 - 0.2 wt.% In.
- 10 25. An alloy as claimed in any one of the preceding claims comprising from 0.01 - 0.3 wt.% Ca.
- 15 26. An alloy as claimed in claim 25 comprising from 0.02 - 0.2 wt.% Ca.
27. An alloy as claimed in any one of the preceding claims comprising from 0.01 - 0.3 wt.% Si.
- 20 28. An alloy as claimed in claim 27 comprising from 0.02 - 0.2 wt.% Si.
29. An alloy as claimed in any one of the preceding claims comprising from 0.008 - 0.3 wt.% Al.
- 25 30. An alloy as claimed in claim 29 comprising from 0.1 - 0.2 wt.% Al.
31. An alloy as claimed in any one of the preceding claims  
30 comprising from 0.01 - 0.3 wt.% Zn.

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32. An alloy as claimed in claim 31 comprising from 0.1 -  
0.2 wt.% Zn.

33. An alloy as claimed in any one of the preceding claims,  
5 wherein said one or more rare earth elements comprises one  
or more (preferably two or more) elements selected from  
cerium, lanthanum, neodymium and praseodymium.

34. An alloy as claimed in any one of the preceding claims  
10 comprising approximately 0.3 wt.% Ag, approximately 0.7 wt.%  
Cu, approximately 0.1 wt.% Bi, up to 0.1 wt.% of at least  
one element selected from the group Ni, Co, Cr and Mn, and  
approximately 0.006 wt.% P.

15 35. An alloy as claimed in any one of the preceding claims  
comprising approximately 0.3 wt.% Ag, approximately 0.7 wt.%  
Cu, approximately 0.1 wt.% Bi, up to 0.1 wt.% of at least  
one element selected from the group Ni, Co, Cr and Mn, and  
from 0.005 - 0.015 wt% Ge.

20

36. An alloy as claimed in any one of the preceding claims  
in the form of a bar, a stick, a solid or flux cored wire, a  
foil or strip, or a powder or paste (powder plus flux  
blend), or solder spheres for use in ball grid array joints  
25 or chip scale packages, or other pre-formed solder pieces.

37. A soldered joint comprising an alloy as defined in any  
one of claims 1 to 36.

30 38. Use of the following solder alloy composition in a ball  
grid array or chip scale package:



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- from 0.08 - 3 wt.% bismuth,  
from 0.15 - 1.5 wt.% copper,  
from 0.1 - 1.5 wt.% silver,
- 5 from 0 - 0.1 wt.% phosphorus,  
from 0 - 0.1 wt.% germanium,  
from 0 - 0.1 wt.% gallium,  
from 0 - 0.3 wt.% of one or more rare earth elements,  
from 0 - 0.3 wt.% indium,
- 10 from 0 - 0.3 wt.% magnesium,  
from 0 - 0.3 wt.% calcium,  
from 0 - 0.3 wt.% silicon,  
from 0 - 0.3 wt.% aluminium,  
from 0 - 0.3 wt.% zinc,

15

and the balance tin, together with unavoidable impurities.

39. Use as claimed in claim 38, wherein the alloy comprises  
from 0.08 to 1 wt.% Bi, preferably from 0.08 to 0.5 wt.% Bi.
- 20 40. Use as claimed in claim 39, wherein the alloy comprises  
from 0.08 to 0.2 wt.% Bi, preferably approximately 0.1 wt.%  
Bi.
- 25 41. Use as claimed in any one of claims 38 to 40, wherein  
the alloy comprises from 0.15 to 1 wt.% Cu, preferably from  
0.5 to 0.9 wt.% Cu.
- 30 42. Use as claimed in claim 41, wherein the alloy comprises  
from 0.6 to 0.8 wt.% Cu, preferably approximately 0.7 wt.%  
Cu.

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43. Use as claimed in any one of claims 38 to 42, wherein the alloy comprises from 0.1 to 1 wt.% Ag, preferably from 0.1 to 0.5 wt.% Ag.
- 5 44. Use as claimed in claim 43, wherein the alloy comprises from 0.2 to 0.4 wt.% Ag, preferably approximately 0.3 wt.% Ag.
- 10 45. Use as claimed in any one of claims 38 to 44, wherein the alloy comprises from 0.001 to 0.1 wt.% phosphorus, preferably from 0.003 to 0.01 wt.% phosphorus.
- 15 46. Use as claimed in claim 45, wherein the alloy comprises from 0.004 to 0.008 wt.% phosphorus, preferably approximately 0.006 wt.% phosphorus.

# INTERNATIONAL SEARCH REPORT

International application No

/GB2005/004609

**A. CLASSIFICATION OF SUBJECT MATTER**  
 B23K35/26 C22C13/00

According to International Patent Classification (IPC) or to both national classification and IPC

**B. FIELDS SEARCHED**

Minimum documentation searched (classification system followed by classification symbols)  
 B23K C22C

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, PAJ, WPI Data, CHEM ABS Data

**C. DOCUMENTS CONSIDERED TO BE RELEVANT**

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X	US 2002/051728 A1 (SATO KOJI ET AL) 2 May 2002 (2002-05-02) cited in the application  pages 2-9, paragraph 143; claims 1-22 -----	1-9, 11-15, 21-24, 34-46
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Further documents are listed in the continuation of Box C.

See patent family annex.

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## INTERNATIONAL SEARCH REPORT

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